



JFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76019

Ichirou MIYAGAWA

Appln. No.: 10/603,937

Group Art Unit: 2861

Confirmation No.: 3417

Examiner: Hai Chi PHAM

Filed: June 26, 2003

For: ARRAY REFRACTING ELEMENT, ARRAY DIFFRACTING ELEMENT AND
EXPOSURE APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 26, 2005, please amend the above-identified application as follows on the accompanying pages.

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